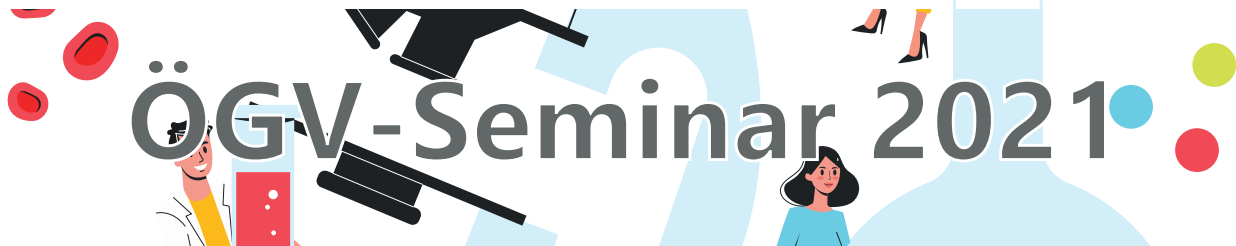


# ÖGV-Seminar 2021



## SCOPE

The Austrian Vacuum Society (ÖGV) invites all PhD students from Austrian universities working in the field of vacuum technology and thin film development to participate in the newly established ÖGV-Seminar to share their work. Other interested persons from academia or industry are invited to discuss recent findings and developments. With this one-day event we aim to bring together the different groups in Austria active in the field to stimulate the exchange of knowledge and to trigger potential collaborations.

**Submission  
Deadline  
08 Sept 2021**

PhD students are invited to submit abstracts for contributions to be presented as a lecture in a focused topic format or as a poster. To allow for evaluation by the Scientific Committee, the abstracts (max. 175 words) should clearly outline the aim of the work and the methods employed, as well as the major results and conclusions.

**PLENARY LECTURE:** Energy considerations in plasma-based deposition of thin films, Prof. Dr. André Anders

Director and CEO Leibniz Institute of Surface Engineering (IOM), Editor-in-Chief Journal of Applied Physics

## FACTS



- › Date & Place: 24 Sept 2021, TU Wien
- › TU Wien, HS Radinger, Building BD (1. OG), Getreidemarkt 9
- › Topical sessions from 9:00 to 17:00 with lunch break
- › Get-together + dinner, 23 Sept 2021, 17:00 (@Building BD)
- › Conference fee: € 80 ,- (25% DISCOUNT FOR MEMBERS)
- › Abstracts & questions: [oegv@iap.tuwien.ac.at](mailto:oegv@iap.tuwien.ac.at)